

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: T. KUMAKI, et al.
Serial No.: 10/572,859
371 Date: JANUARY 11, 2007
For: PHOTSENSITIVE ELEMENT, RESIST PATTERN FORMATION
METHOD AND PRINTED WIRING BOARD PRODUCTION
METHOD
Group AU: 1795
Examiner: Amanda C. Walke
Confirm. No: 9435

AMENDMENT

Mail Stop: AMD

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

March 11, 2009

Sir:

In response to the Office Action mailed December 11, 2008, please amend the above-identified application as listed in the following, and as set forth on the following pages:

AMENDMENTS TO THE CLAIMS; and

REMARKS are included following the amendments.